Impact of Current Collecting Grids on the Scalability of 3-Terminal Perovskite/Silicon Tandems with Bipolar Transistor Architecture

Original

Availability:
This version is available at: 11583/2985153 since: 2024-01-16T13:27:44Z

Publisher:
IEEE

Published
DOI:10.1109/PVSC48320.2023.10360071

Terms of use:
This article is made available under terms and conditions as specified in the corresponding bibliographic description in the repository

Publisher copyright
IEEE postprint/Author's Accepted Manuscript

©2023 IEEE. Personal use of this material is permitted. Permission from IEEE must be obtained for all other uses, in any current or future media, including reprinting/republishing this material for advertising or promotional purposes, creating new collecting works, for resale or lists, or reuse of any copyrighted component of this work in other works.

(Article begins on next page)
Impact of current collecting grids on the scalability of 3-terminal perovskite/silicon tandems with bipolar transistor architecture

Gemma Giliberti1, Federica Cappelluti1, Senior Member, IEEE

Department of Electronics and Telecommunications, Politecnico di Torino, Corso Duca degli Abruzzi 24, 10129 Torino, Italy

Abstract—The heterojunction bipolar transistor (HBT) structure is an attractive solution for developing three-terminal perovskite/silicon tandem solar cells compatible with dominant silicon photovoltaic devices, such as PERC and heterojunction. However, in contrast to three-terminal tandems based on interdigitated back contact silicon cells, the three-terminal HBT requires the implementation of the third contact at the base (middle) layer. To this aim, the simplest solution is to access the base layer from the cell front side by implementing a grid layout with top interdigitated contacts (TIC). In this work, we elaborate on the feasibility of the HBT structure for 3T perovskite/silicon tandem solar cells. We report, based on optical and drift-diffusion simulations, proof-of-concept designs with high efficiency potential, and we analyze, with the aid of circuit level simulations, the implications of a TIC grid layout in the perspective of scaling up to large areas. Our results show that the HBT architecture is a promising candidate for developing 3T perovskite/silicon tandem solar cells compatible with industry standard silicon photovoltaics.

Index Terms—perovskite-silicon tandem solar cell, three-terminal, power loss, physics-based simulation, circuit-level simulation.

I. INTRODUCTION

Perovskite/silicon (PVS) tandem solar cells are among the most promising candidates for next generation photovoltaics [1]. They recently achieved the efficiency record of 32.5% [2], approaching that of costly III-V double-junction solar cells [2]. Besides two- and four-terminal approaches, three-terminal (3T) tandems based on interdigitated back contact (IBC) silicon cells are currently being investigated [3], in view of the advantages of the 3T approach in terms of energy yield in the field [4].

The 3T-HBT solar cell [5], [6] offers an attractive alternative for the development of 3T PVS tandem solar cells suitable for integration with industry standard photovoltaic technologies such as PERC and heterojunction (HTJ) silicon cells. The 3T-HBT solar cell has a theoretical (material-based) efficiency limit as high as that of a perfectly matched 2-terminal tandem, but with a simpler structure because the top and bottom subcells are seamlessly connected, without the need of any additional interconnecting layer. However, in the perspective of large-area devices, the drawback might come from the realization of the third terminal at the base layer. In fact, implementing the 3T-HBT in the PERC or HTJ silicon platforms requires, as simplest possible solution, adopting a top-interdigitated-contact (TIC) [7], whose implications in terms of shading and resistive losses must be carefully evaluated.

In this work, we report a simulation study of 3T-HBT PVS tandem solar cells aimed at investigating their efficiency potential and perspectives for scaling up to large areas. We present proof-of-concept 3T-HBT PVS devices designed by means of optical and transport simulations and analyze the power losses induced by the current collecting grid and how they scale with the cell area based on circuit-level simulations.

II. DEVICE & METHODS

Fig. 1(a) sketches a 3T-HBT PVS tandem made of a n-i-p PVK subcell on top of a planar homojunction n+p Si bottom cell with design parameters in line with [1]. From the top, the TCO (34 nm) / PTAA (11 nm) / PVK(480 nm) layer stack constitutes the p-emitter layer; the SnO2 (25 nm) electron transport layer (ETL) and n-Si (150 nm) one form the base layer on top of the 150 µm thick p-type c-Si collector. The cell uses a 92 nm thick MgF antireflection coating. As shown in Fig. 1(b,c), emitter and base are accessed from the top with a TIC layout, with the base contact (Z) placed on the n-Si layer and the emitter contact (T) on the TCO layer. A full-area contact (R) is used at the collector.
Under illumination, photogenerated electrons and holes induce current flows collected at the T, Z and R terminals. As depicted in Fig. 1, carrier transport through materials with finite conductivity and contacts cause power loss mechanisms that can be modeled as resistive effects. The resulting equivalent circuit model of the 3T-HBT is shown in Fig. 2. It consists of the Ebers-Moll circuit of the intrinsic device under illumination [3, 8] completed by parasitic series resistances at each terminal. In particular, as summarized in Table I, the equivalent base and emitter series resistance account for the contribution of lateral current flow ($R_{S,lateral}$) and of contact ($R_c$) and finger ($R_{finger}$) resistance of the current collecting grids. These are calculated based on the equivalent lumped circuit model of the unit cell of the metal grid (Fig. 1) according to the expressions given in Table I [7, 9]. At this stage, the analysis does not include the busbars.

The parameters of the Ebers-Moll model are extracted by fitting the current-voltage characteristics of the intrinsic 3T-HBT obtained by quasi-1D coupled optical-electrical simulations (which do not account for lateral transport neither for grid shading and resistive loss). Here, the photogeneration profile is computed by using the transfer matrix method and then given as input to the classical Poisson-drift-diffusion transport model. The approach was validated against experimental data in previous works [8, 10], where all the simulation material parameters assumed are available.

### III. RESULTS & DISCUSSION

Fig. 3 shows the External Quantum Efficiency and $J-V$ characteristics of the subcells of the 3T-HBT PVS tandem under study, and the $J-V$ characteristics reproduced by the Ebers-Moll model. Transport simulations showed that band discontinuities and materials resistivity are such that the two subcells substantially work as independent, i.e. no appreciable transistor effect occurs through the SnO$_2$/n$^+$-Si base [8]. The intrinsic device has high efficiency of $\approx 29.4\%$.

In order to analyze the influence of the TIC grid on the device performance and scalability to large areas, we consider typical metal grid parameters [9, 11] as summarized in Table II. A shading loss factor of $2w_i/d_t$ is applied to the bottom sub-cell, and $3w_i/d_t$ to the top one, assuming for the etched region, needed to access the base layer, a width twice that of the metal finger.

First, we consider relatively small devices ($l_t = 1.5\, \text{cm}$), in which resistive effects are dominated by lateral transport, and study the efficiency loss in terms of finger spacing and sheet resistance of the base layer, with fixed ITO/TCO emitter sheet resistance ($\approx 274\, \Omega/\square$). The HBT base region is composed of the bottom layer of the PVK subcell and the top layer of the Si one, therefore its sheet resistance is strongly dependent on the HBT configuration (p-n-p or n-p-n) and bottom cell technology. As seen in Fig. 4 for $R_{base}^{sheet}$ up to $100\, \Omega/\square$ (representative of PVS tandems on homojunction c-Si cells as in Fig. 2) the efficiency loss can be minimized to less than 3%.
Fractional power loss ($\propto$ total base resistance is about 1/3 of the emitter one, but the
associated to the lateral transport across base and emitter. The
finger distance 1.5 mm. Here, the dominant resistive path is
and device optimization, and by developing more advanced
sheet resistance. Such power loss could be reduced by material
finger lengths up to about 6-8 cm depending on the base
interdigitated front grid can keep power losses below 5% for
as the cell area and finger length increase, the resistive effects
is about 70% higher than that one of the emitter. Therefore,
corresponds to the sum of the top and bottom subcell currents,
PVS in Fig. 1 with
with 1.5 cm x 1.5 cm area and (b) associated fractional resistive power loss.
with finger distance of 1.5 mm or larger. On the other hand,
for PVS 3T-HBT tandems on HTJ silicon cells, the high sheet
resistance of the a-Si:H layers ($\approx 10^5 \Omega$/sq) must be mitigated
by exploiting a highly conductive transport layer for the PVK
top cell, such as the SnO$_2$ layer used in the $p$-$n$-$p$ HBT under
study (sheet resistance $\approx 10^2 \Omega$/sq).

Fig. 5 shows the emitter and base resistance and the corresponding fractional power loss estimated for the 3T-HBT
PVS in Fig[1] with $R_{sh}^{Base} = 74 \Omega/\square$, finger length 1.5 cm,
finger distance 1.5 mm. Here, the dominant resistive path is
associated to the lateral transport across base and emitter. The
total base resistance is about 1/3 of the emitter one, but the
fractional power loss ($\propto R_f J_f^2$) associated to base and emitter
grids is comparable since the current through the base, which
corresponds to the sum of the top and bottom subcell currents,
is about 70% higher than that of one of the emitter. Therefore,
as the cell area and finger length increase, the resistive effects
of the base grid become the dominant cause of efficiency loss.

In Fig. 4 we analyze the variation of efficiency loss with
scaling up of the finger length for two values of the base
sheet resistance, representative of 3T-HBT tandems on ho-
mojunction and heterojunction silicon cells. An optimized
interdigitated front grid can keep power losses below 5% for
finger lengths up to about 6-8 cm depending on the base
sheet resistance. Such power loss could be reduced by material
and device optimization, and by developing more advanced
grid designs, for example employing overlapped contact grids
to reduce shading losses. Overall, these results show the
potential, even in the perspective of scaling up to large areas,
of using the HBT architecture to develop high efficiency three-
terminal perovskite/silicon tandems that can be integrated with
industry standard silicon bottom cells.

IV. ACKNOWLEDGEMENTS

This research was partly funded by the ECSEL Joint Un-
dertaking (JU) under grant agreement No 101007247.

REFERENCES

J. C. Goldschmidt, M. Bivour, S. W. Glunz, and M. Hermle, “The
race for the best silicon bottom cell: Efficiency and cost evaluation
of perovskite–silicon tandem solar cells,” Progress in Photovol-


brecht, and L. Korte, “Three-terminal perovskite/silicon tandem solar
 cells with top and interdigitated rear contacts,” ACS Applied Energy

“Energy yield advantages of three-terminal perovskite-silicon tandem

 solar cell for high-efficiency photovoltaic conversion,” Nature commu-
nications, vol. 6, no. 1, pp. 1–6, 2015.

[6] E. Antolín, M. H. Zehender, S. A. Svatek, M. A. Steiner, M. Martínez,
I. García, P. García-Linares, E. L. Warren, A. C. Tamboli, and A. Martí,
“Progress in three-terminal heterojunction bipolar transistor solar cells,”
Progress in Photovoltaics: Research and Applications, vol. 30, no. 8,

cells = células solares de tres terminales tipo transistor bipolar de
deterioro,” PhD Thesis, Universidad Politécnica de Madrid, April

perovskite/silicon solar cell with bipolar transistor architecture,” Energies,
vol. 15, no. 21, 2022.

cells: Evaluations and optimizations of the electron contact,” PhD

three-terminal tandems based on bipolar transistor structure,” in Physics,
Simulation, and Photonic Engineering of Photovoltaic Devices XI,
for Optics and Photonics. SPIE, 2022, p. 1199602.

and S. De Wolf, “Electrode metallization for scaled perovskite/silicon
tandem solar cells: Challenges and opportunities,” Progress in Photov-